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CONFIRMATION NO. 8996

<b>SERIAL NUMBER</b> 10/530,562	<b>FILING OR 371(c) DATE</b> 04/07/2005 <b>RULE</b>	<b>CLASS</b> 117	<b>GROUP ART UNIT</b> 1765	<b>ATTORNEY DOCKET NO.</b> Q87267
<b>APPLICANTS</b> Masahiko Hata, Tsuchiura, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/13067 10/10/2003 <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-301059 10/15/2002				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and <u>Chen</u> <u>5H</u> Acknowledged Examiner's Signature Initials		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 1	<b>TOTAL CLAIMS</b> 14
				<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> 23373				
<b>TITLE</b> Production method for thin-film crystal wafer, semiconductor device using it and production method therefor				
<b>FILING FEE RECEIVED</b> 1260	<b>FEES:</b> Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	